

**Search Notes**

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Examiner

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Applicant(s)/Patent under  
Reexamination

HSIEH, YOU-JUN

Art Unit

2629

**SEARCHED**

Class	Subclass	Date	Examiner
345	168	3/10/2007	JL
345	169	3/10/2007	JL
345	170	3/10/2007	JL
345	171	3/10/2007	JL
345	172	3/10/2007	JL
341	22	3/16/2007	JL

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner
PGPUB	Search	3/10/2007	JL

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
East search and copy attached.	3/10/2007	JL